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67,200-447; TSMC 00-0890 Serial Number 09/975,855

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TO:

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

FROM:

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DATE:

9 March 2004

REF:

Applicant: Elsieh et al.

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Examiner : Saleha R Mohamedulla

Art Unit Title

1756

: Gap Forming Pattern Fracturing Method for Forming Optical

Proximity Corrected Masking Layer

## AMENDMENT AND RESPONSE TO OFFICE ACTION MADE FINAL

Sir:

In response to an office action mailed on 12 February 2004, please consider the following amendments and remarks pertaining to the above referenced application.

There are no amendments to the specification or drawings. Amendments to the claims are contained within A Listing of the Claims that begins on page 2 of this paper. Remarks begin on page 8 of this paper.

## CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office at facsimile number 703-872-9311, on April 6, 2004.

- 4/22/04